



1765  
#8  
41-00

35.C12395 CIP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
YOSHIHIKO FUKUMOTO ) : Examiner: Unassigned  
Application No.: 09/429,530 ) : Group Art Unit: 1765  
Filed: October 28, 1999 ) :  
For: METHOD FOR FABRICATING ) :  
SEMICONDUCTOR DEVICE : June 12, 2000

RECEIVED  
JUN 14 2000  
TC 1700 MAIL ROOM

Assistant Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The listed document was cited in a Korean Search Report dated March 21, 2000, in a Korean patent application corresponding to the above-identified application. A copy of this search report is included.


The concise explanation of relevance for this non-English document is provided in the form of an English language abstract.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicant  
Registration No. 42,667

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

EFH:meg